

FORM PTO-1449
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
RD-28,667-1

SERIAL NO.

INFORMATION DISCLOSURE STATEMENT BY APPLICANT
LIST OF ITEMS

NOV 12 2003

Applicant
Marc SchaepkensFiling Date
11/27/01 Group
1763**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
A1	6,365,016	4/2/02	Iacovangelo et al.			
A2	6,397,776	6/4/02	Yang et al.			
A3						
A4						
A5						
A6						
A7						
A8						
A9						
A10						
A11						
A12						
A13						
A14						
A15						
A16						

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
B1						
B2						
B3						
B4						
B5						

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, etc.)

C1	PCT Search Report dated October 15, 2003.
C2	Journal of Non-Crystalline Solids, "Fast Deposition of Microcrystalline Silicon with an Expanding Thermal Plasma", pp. 98-102, 2002.
C3	Diamond and Related materials, <i>Plasma Chemistry During Deposition of a-C:H</i> , Volume 11, pp. 989-993, 2002.

EXAMINER

P. Hassanzadeh

DATE CONSIDERED

11-23-04

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant